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(72) Elsner, Frederick H., US

(72) Raggio, William A., US

(72) Woolf, Lawrence D., US

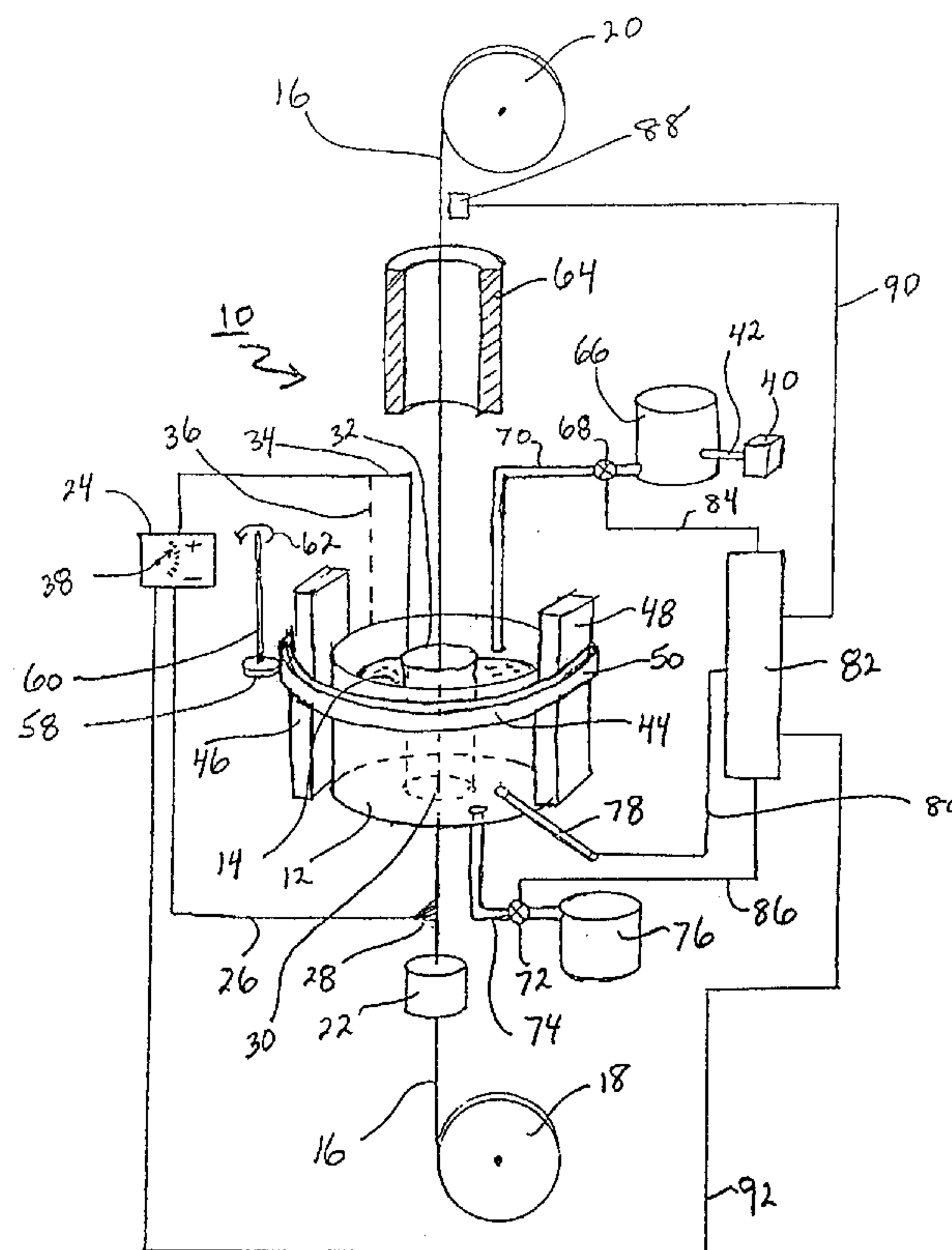
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(54) **METHODE ET APPAREIL POUR LA FABRICATION DE FIBRES
METALLIQUES REVETUES DE CERAMIQUE
SUPRACONDUCTRICE**

(54) **APPARATUS AND METHOD FOR MANUFACTURING A
CERAMIC SUPERCONDUCTOR COATED METAL FIBER**



(57) An apparatus and method for manufacturing a ceramic superconductor coated metal fiber comprises a container for holding a nonaqueous solution in which particles of superconductor material are colloiddally suspended to form a slurry. A voltage source is provided to influence the slurry with an electric field and a magnet device is provided to influence the slurry with a magnetic field. The magnetic field is oriented relative to the fiber to align the superconductor particles of the slurry in a desired orientation for subsequent attachment onto the surface of the fiber. The voltage source is connected to the metal fiber to electrically bias the fiber as it is drawn through the slurry. Consequently, charged superconductor particles in the slurry attach to the electrically biased fiber. Subsequently, the coated fiber is heated to sinter the aligned particles and establish a ceramic superconductor shell on the metallic fiber substrate.



ABSTRACT

An apparatus and method for manufacturing a ceramic superconductor coated metal fiber comprises a container for holding a nonaqueous solution in which particles of superconductor material are colloidally suspended to form a slurry. A voltage source is provided to influence the slurry with an electric field and a magnet device is provided to influence the slurry with a magnetic field. The magnetic field is oriented relative to the fiber to align the superconductor particles of the slurry in a desired orientation for subsequent attachment onto the surface of the fiber. The voltage source is connected to the metal fiber to electrically bias the fiber as it is drawn through the slurry. Consequently, charged superconductor particles in the slurry attach to the electrically biased fiber. Subsequently, the coated fiber is heated to sinter the aligned particles and establish a ceramic superconductor shell on the metallic fiber substrate.

PAT: 10725-21

FIELD OF THE INVENTION

The present invention relates to apparatus and methods for manufacturing superconductors. More particularly, the present invention relates to an apparatus which is useful for coating a metallic substrate with a superconductor material. The present invention is particularly, but not exclusively, useful for coating a metal fiber substrate with ceramic superconductor.

BACKGROUND OF THE INVENTION

It is now well known that certain materials exhibit exceptional electrical conductive properties which have earned them the distinctive designation of superconductors. Though many superconductor materials are known, ways in which superconductor materials can be incorporated into commercially viable products are not so well known. Indeed, in recent years, extensive efforts have been made to solve many of the problems which confront the manufacturers of superconductor products.

One particular class of superconductor materials which has attracted a great deal of interest for its potential use in commercial products is the so-called 1-2-3 materials that include rare earth elements (RE) and are from the group identified as $RE Ba_2Cu_3O_{7-x}$. For commercial purposes, it has been determined that these materials are particularly effective in a ceramic form which is made by sintering very fine crystalline particles of 1-2-3. Of importance to the present

1 invention is the fact that, due primarily to properties of the
2 rare earth elements in the particular crystalline structure of
3 these 1-2-3 particles, they can be effectively influenced by a
4 magnetic field before they are sintered. Importantly, it is
5 desirable that the superconductor particles have anisotropic
6 magnetic susceptibilities. Further, since the particles can
7 also be charged before they are sintered, they can also be
8 influenced by an electric field.

9 With the above in mind, one problem which has heretofore
10 confronted persons skilled in the superconductor art concerns
11 how to support the inherently brittle superconductor ceramic.
12 An obvious solution is to use some form of a supporting
13 substrate. Though substrates of various forms may be used, for
14 certain applications a substrate in the form of a fiber, a wire
15 or a ribbon is ideal. Unfortunately, effectively placing a
16 superconductor ceramic on such a substrate is not easy. For
17 one thing, the ceramic needs to be directly attached to the
18 substrate. Furthermore, the superconductor layer should
19 preferably be of uniform thickness and relatively thin. The
20 present invention recognizes that one way in which to use these
21 substrates is to deposit a thin layer of very fine particles of
22 1-2-3 on the substrate before they are sintered into a ceramic.

23 Electrophoresis is a well known process for coating metal
24 substrates which involves the motion of colloidal particles
25 suspended in a fluid medium due to the influence of an electric
26 field on the medium. Although some superconductor materials

1 are not adversely affected by water, unfortunately, the 1-2-3
2 material deteriorates when exposed to moisture. Thus, when
3 1-2-3 superconductor materials are used, the fluid mediums
4 typically used for electrophoresis, which include water, can
5 not be used in a procedure to coat a metal substrate with fine
6 superconductor particles. The present invention, however,
7 recognizes that an electrophoresis procedure can be
8 accomplished using a nonaqueous solution as the fluid medium.
9 Further, the present invention recognizes that a magnetic field
10 will affect the superconductor particles in the medium to align
11 them on the substrate in an optimal orientation.

12 In light of the above, it is an object of the present
13 invention to provide an apparatus for attaching superconductor
14 particles to a metal substrate. Another object of the present
15 invention is to provide an apparatus which uses a nonaqueous
16 fluid medium in an electrophoresis procedure to coat a metallic
17 substrate with superconductor particles. Yet another object of
18 the present invention is to provide an apparatus which
19 magnetically aligns superconductor particles in a desired
20 orientation on a metallic substrate during the coating
21 process. Still another object of the present invention is to
22 provide a method for coating a metal substrate with
23 magnetically aligned superconductor particles. Another object
24 of the present invention is to provide an apparatus for coating
25 metallic substrates that is relatively easy to manufacture,
26 relatively simple to operate and cost effective.

SUMMARY OF THE INVENTION

A preferred embodiment of the apparatus for manufacturing a ceramic superconductor coated metal fiber comprises a container for holding a nonaqueous solution of isopropanol and ethanolamine in which charged particles of superconductor material are suspended to form a slurry. An electrode (e.g. anode) is electrically connected to a voltage source and is placed in electrical contact with the slurry. Similarly, the metal fiber substrate is electrically connected to the voltage source to establish a counterelectrode (e.g. cathode) and is submersed in the slurry. The voltage of the voltage source is then set to influence the slurry with an electric field having a level which causes the charged superconductor particles in the slurry to attach to the metal fiber substrate counterelectrode and coat the fiber with superconductor material.

A magnet device may be positioned externally to the container to influence the slurry with a magnetic field. Depending on the magnetic properties of the particular superconductor particles and the desired alignment of these particles on the fiber substrate, the field can be generally directed either parallel or perpendicular to the longitudinal axis of the fiber substrate. Further, in order to enhance uniform coating of the fiber in the presence of this magnetic field, the apparatus may have means to rotate either the fiber or the magnet device while the fiber is being drawn through the

1 solution. Additionally, the apparatus may comprise means to
2 continuously feed the metal fiber substrate into the slurry and
3 to respectively withdraw the fiber therefrom once it is coated
4 with superconductor particles.

5 In addition to the basic elements of the present invention
6 which comprise the slurry container, magnet device and voltage
7 source, means may be provided to maintain superconductor
8 particle concentration in the nonaqueous solution at a
9 substantially constant level. This is done by an incorporated
10 control system which adds high concentration slurry through a
11 supply valve on a holding tank to the slurry in the container
12 and which simultaneously draws off low concentration slurry
13 from the container through a drain valve on the container. A
14 sampling probe can be provided and inserted into the container
15 to take readings of the superconductor concentration levels in
16 the slurry. A signal proportional to a reading can be used by
17 electronic componentry to appropriately operate the supply
18 valve and drain valve to maintain a substantially constant
19 level of superconductor particle concentration in the
20 container.

21 In the method for manufacturing a ceramic superconductor
22 coated metal fiber, fine particles of superconductor material
23 are suspended in a solution comprising isopropanol and
24 ethanolamine. The resultant slurry is ultrasonically agitated
25 or ball milled to disperse, charge and deagglomerate the
26 particles prior to being influenced by the electric field. The

1 fiber substrate is electrically connected to a voltage source
2 to bias the fiber and it is then drawn through the slurry.
3 While the fiber is being drawn through the slurry in a
4 continuous operation, either the fiber or the magnet may be
5 rotated in order to achieve a more uniform coating of magnet-
6 ically aligned superconductor particles. After leaving the
7 slurry with its superconductor particle coating, the coated
8 fiber may be heated in the range of approximately 900°C to
9 950°C to sinter the superconductor particles and create a
10 ceramic shell on the substrate.

11 The novel features of this invention, as well as the
12 invention itself, both as to its structure and its operation,
13 will be best understood from the accompanying drawings, taken
14 in conjunction with the accompanying description, in which
15 similar reference characters refer to similar parts, and in
16 which:

18 BRIEF DESCRIPTION OF THE DRAWINGS

19 Figure 1 is a schematic of the apparatus with various
20 portions shown in perspective, in cross section or in phantom
21 for clarity;

22 Figure 2 is a perspective view of an alternate embodiment
23 of the magnet device of the apparatus;

24 Figure 3 is an isometric view of an idealized super-
25 conductor crystalline particle; and
26

1 Figures 4A and 4B illustrate desired alignments of
2 superconductor particles in different magnetic fields.

3
4 DESCRIPTION OF THE PREFERRED EMBODIMENT

5 Referring initially to Figure 1, the apparatus for
6 manufacturing a ceramic superconductor coated metal fiber is
7 shown and generally designated 10. As shown, apparatus 10
8 includes a container 12 for holding a slurry 14 in which very
9 fine particles of superconductor material are suspended.
10 Preferably, the superconductor material is from the group
11 identified as RE Ba₂Cu₃O_{7-x} (where x is in the range of 0-1).
12 Importantly, when this preferred superconductor material is
13 used, slurry 14 comprises a nonaqueous solution. Further, the
14 nonaqueous solution should be nonreactive with the
15 superconductor material and preferably comprise a solvent, such
16 as isopropanol, with a relatively small amount (e.g.
17 approximately 0.1-5% of the solution) of an additive, such as
18 ethanolamine, which is dissolved in the solvent to enhance the
19 ability of the superconductor materials suspended therein to
20 carry an electrical charge. It will be understood by the
21 skilled artisan that other additives, such as dibutylamine,
22 urea, or a product commercially known as Emphos P21, may be
23 used instead of ethanolamine. In any event, the slurry 14 must
24 remain effectively moisture-free and both the solvent
25 (isopropanol) and the additive (ethanolamine) in slurry 14
26 should evaporate or decompose at relatively low temperatures

(i.e. somewhere below 300°C) in order to prevent subsequent reactions of these ingredients with the superconductor material.

In accordance with the present invention, a metallic substrate 16, on which the superconductor particles suspended in slurry 14 are to be coated, is fed into or suspended in the slurry 14. This substrate 16 may be formed as either a ribbon or a wire fiber. The actual form or configuration of substrate 16 is not, however, a limiting consideration. In fact, any configuration will work so long as it can function effectively as an electrode.

In addition to its electrical properties, substrate 16 should not interdiffuse with the superconductor particles. Thus, substrate 16 can be made of an inert metal such as gold or silver. When, however, a less expensive, more cost effective material is used (i.e. one which is not noble), substrate 16 will preferably lend itself to the establishment of an oxide barrier on its surface which will minimize the interdiffusion of substrate 16 with the superconductor particles. Thus, substrate 16 should either be made of an oxide forming material, such as the wire commercially available as Hoskins™ 875, or have a thin oxide layer deposited on it, such as Barium Zirconate (BaZrO_3). Preferably, substrate 16 is made of an oxide forming material such as used for the wire of Hoskins 875. This is so because such a substrate 16 can be electrophoretically coated with superconductor particles at

Regents Square I, Suite 750
4275 Executive Square
La Jolla, California 92037
Telephone (619) 435-5700
Telex (619) 535-9810

1 relatively low temperatures before being subjected to the much
2 higher temperatures which are necessary to form an oxide
3 barrier on the surface of substrate 16 (e.g. 850°C). In this
4 regard, it is important to recognize that when an oxide forming
5 material is used, the electrophoresis process necessarily
6 precedes formation of the oxide barrier because an oxide
7 barrier will tend to electrically insulate substrate 16.
8 Suitable oxide forming materials for substrate 16 are
9 materials, such as alumel or the commercially available
10 material discussed above and known as Hoskins 875. Such
11 materials will create an effective oxide barrier between
12 substrate 16 and the superconductor coating during subsequent
13 procedures wherein the superconductor particles are sintered
14 into a ceramic. Examples of such procedures are disclosed in a
15 co-pending application for an invention entitled "Substrate for
16 Ceramic Superconductor" which is assigned to the same assignee
17 as the present invention. On the other hand, when a substrate
18 16 has a preformed oxide barrier, the barrier should not
19 electrically insulate the substrate 16 to the point where an
20 electrophoresis process is made ineffectual. For example, a
21 suitable material in this case would be Nicrosil coated with
22 Barium Zirconate.

23 As shown in Figure 1, substrate 16 is fed from a supply
24 spool 18 and through slurry 14 in container 12 to a take-up
25 spool 20. More specifically, after leaving supply spool 18,
26 substrate 16 is passed through a precleaner 22 (e.g. a furnace

1 or a solvent in an ultrasonic bath) where it is cleaned of dust
2 and other debris which may have settled onto the substrate 16
3 during handling. As also shown in Figure 1, substrate 16 is
4 electrically biased. For this purpose, a voltage source 24 is
5 placed in electrical contact with substrate 16 through line
6 conductor 26 by any means known in the art, such as brush 28.
7 Further, it will be appreciated that voltage source 24 could be
8 a device, well known in the pertinent art, which provides a
9 constant current. Also, though not shown, it will be
10 appreciated that substrate 16 can be electrically biased by any
11 direct electrical connection between voltage source 24 and
12 substrate 16. Regardless, after leaving precleaner 22,
13 substrate 16 is then passed into container 12 via inlet 30.

14 In addition to being electrically connected with substrate
15 16, voltage source 24 is also electrically connected with an
16 open-ended metallic foil cylindrical tube 32. As shown in
17 Figure 1, tube 32 is submersed in slurry 14 and is electrically
18 connected to voltage source 24 via line 34. With this
19 arrangement, slurry 14 in container 12 is influenced by the
20 electric field established between an electrode (i.e. tube 32)
21 and a counterelectrode (i.e. substrate 16). Alternatively,
22 tube 32 can be eliminated and voltage source 24 directly
23 connected to container 12 via line 36. This connection will
24 then establish container 12 as the electrode of the apparatus
25 10. This, of course, requires that container 12 be made of an
26 electrically conducting material.

1 As shown in Figure 1, tube 32 is established as the anode
2 and substrate 16 is established as the cathode. It will be
3 appreciated by skilled artisans, however, that the charges on
4 electrodes and counterelectrodes can be alternated and,
5 further, that the manipulation of rheostat 38 on voltage source
6 24 will vary the level of the voltage potential between anode
7 and cathode. Typically, voltages of from 1-100 volts and
8 corresponding currents in the range of 10 microamps to 1
9 milliamp are effective for the purposes of the present
10 invention. Further, it is to be appreciated that rheostat 38
11 (or a digital voltage source) can be used to establish the
12 voltage levels of the electric field influencing slurry 14 and
13 thereby effectively establish the thickness of the coating of
14 superconductor particles on substrate 16.

15 While varying the voltage level in slurry 14 is, perhaps,
16 the most practical way by which to control coating thickness,
17 it will be appreciated that other factors also affect this
18 thickness. For instance, the concentration of superconductor
19 particles in slurry 14, the time in which substrate 16 is
20 submersed in slurry 14, and the mobility of the superconductor
21 particles through slurry 14 are all factors which affect the
22 electrophoresis process.

23 The electric field influencing slurry 14 is set to cause
24 the superconductor particles, which are colloiddally suspended
25 in the slurry 14, to migrate toward substrate 16 and become
26 attached thereto. This process will, of course, require that

1 the superconductor particles carry a charge. To accomplish
2 this, the superconductor particles are mixed with the
3 nonaqueous solution and then agitated. Effective agitation can
4 be done either ultrasonically or by milling the particles in a
5 manner well known in the pertinent art. Although slurry 14
6 should not be vibrated once it is placed into container 12, an
7 effective way in which slurry 14 may be vibrated is by
8 ultrasonic energy which is generated by an ultrasonic source 40
9 that is operatively connected to tank 66. A transducer probe
10 42 extends from source 40 into slurry 14 in container 66 to
11 agitate the superconductor particles therein to charge the
12 particles in a manner well known in the art. It will be
13 recalled that the additive ethanolamine in slurry 14 is also
14 intended to enhance the charge on superconductor particles.

15 An important feature of apparatus 10 is that slurry 14, in
16 addition to being influenced by an electric field, is also
17 influenced by a magnetic field. For this purpose, a magnet
18 device 44 is provided. In Figure 1, the magnet device 44 is
19 shown as a pair of permanent magnets, respectively designated
20 46 and 48, which are connected together by a flux return
21 element 50 and positioned externally to container 12 on
22 substantially opposite sides thereof. With this configuration,
23 slurry 14 is effectively influenced by a magnetic field whose
24 strength and uniformity is dependent, in part, on the size of
25 magnets 46, 48 and whose flux lines within slurry 14 are
26

1 substantially aligned in a direction which is perpendicular to
2 the longitudinal axis of substrate 16.

3 In an alternate embodiment, a magnet device 52, comprising
4 a solenoid winding 54, as shown in Figure 2, may be used. The
5 magnetic field strength of this magnet device 52 will depend,
6 in part, on the current in winding 54 and the direction of the
7 flux lines generated by magnet device 52 will be in a direction
8 which is substantially parallel to the longitudinal axis of
9 substrate 16. From the discussion below, it will be seen that
10 it is important for the direction of flux to be compatible with
11 the magnetic properties of the 1-2-3 particles.

12 An exemplary configuration of a superconductor particle is
13 shown as plate 56 in Figure 3. In this form, it is known that
14 the critical current densities (J_c) of the plate 56 vary
15 according to the axis along which current flows. Specifically,
16 J_c in both the "a" and "b" directions shown in Figure 3 are on
17 the order of thirty (30) times greater than J_c in the "c"
18 direction. Accordingly, in order to optimize current flow in
19 the resultant product, it is desirable if plates 56 are
20 properly oriented on substrate 16 with their respective "c"
21 directions substantially perpendicular to the longitudinal axis
22 of substrate 16. The magnetic field generated by magnet device
23 44 or magnet device 52 is intended to accomplish this.

24 Fortunately, with the use of RE $Ba_2Cu_3O_{7-x}$ (i.e. 1-2-3) as
25 the superconductor material, the orientation of a plate 56 in a
26 magnetic field of flux H is, at least to some extent,

1 predictable. Specifically, some rare earth 1-2-3 materials
2 orient in a flux field H with their "c" direction parallel to
3 the lines as shown in Figure 4A, while others orient themselves
4 with their "c" direction perpendicular to the lines of flux as
5 shown in Figure 4B. For example, the rare earth elements which
6 orient with the "c" direction parallel to H include Yttrium
7 (Y), Neodymium (Nd), Samarium (Sm), Dysprosium (Dy) and Holmium
8 (Ho). On the other hand, the rare earth elements which orient
9 with the "c" direction perpendicular to H include Europium
10 (Eu), Erbium (Er), Thulium (Tm) and Ytterbium (Yb). Thus,
11 magnet device 44 may be better suited for use with some rare
12 earth superconductors, while magnet device 52 will be better
13 suited for the others.

14 In the particular case shown in Figure 4A, where plate 56
15 orients with its "c" direction parallel to H, there is the
16 potential for a nonuniform anisotropic coating of substrate 16
17 due to the relative thinness of plate 56 in its "c"
18 direction. To overcome this potential problem, substrate 16
19 can be rotated during the coating process or the magnet device
20 itself can be rotated. Though not shown, it will be
21 appreciated that substrate 16 may be rotated by any means well
22 known in the art. Further, substrate 16 need not necessarily
23 pass through slurry 14. Instead, substrate 16 may be suspended
24 in slurry 14 and rotated therein. In any case, to avoid an
25 anisotropic coating, it is necessary to charge substrate 16 and
26 rotate it in slurry 14 to obtain a uniform coating of the

1 magnetically influenced superconductor particles. Referring
2 back to Figure 1, it will be appreciated that magnet device 44
3 can be slidably mounted on container 12 for rotation with
4 respect thereto. A roller 58 can be operatively engaged with
5 magnet device 44, by any means well known in the art, so that
6 rotation of roller 58 about an axis 60 in the direction of
7 arrow 62 will cause magnet device 44 to rotate about container
8 12 while maintaining flux lines in slurry 14 substantially
9 perpendicular to the longitudinal axis of substrate 16. Thus,
10 an anisotropic coating of substrate 16 can be obviated.

11 As shown in Figure 1, magnets 44, 46 partially extend
12 above container 12. Accordingly, the superconductor particles
13 from slurry 14 which attach to substrate 12 continue to be
14 influenced by a magnetic field even after passing through
15 slurry 14. This configuration is established in order to keep
16 the superconductor particles properly aligned on substrate 16
17 during the evaporation of nonaqueous solution, and prior to
18 sintering.

19 An oven 64 is provided to sinter the superconductor
20 particles which are attached to substrate 16 into a ceramic.
21 The ceramic superconductor coated substrate 16 can then be
22 wound onto take-up spool 20 and used thereafter as desired.

23 During the continuous process of coating substrate 16 with
24 superconductor particles, it may be desirable to maintain the
25 concentration of superconductor particles in slurry 14 at a
26 substantially constant level. To accomplish this, a slurry 14

1 having slightly higher superconductor particle concentration
2 levels than desired for use in container 12 is provided and
3 held in supply tank 66. The operation of supply valve 68 will
4 open pipe 70 and allow high concentration slurry 14 from supply
5 tank 66 to be introduced into the slurry 14 in container 12.
6 Simultaneously, operation of drain valve 72 allows low
7 concentration slurry 14 in container 12 to be withdrawn from
8 container 12 through pipe 74 into holding tank 76.

9 The maintenance of superconductor concentration levels in
10 container 12 can be accomplished with a closed loop feedback
11 control system. In this system, a probe 78 is inserted into
12 slurry 14 and is used to test samples of slurry 14 for
13 viscosity and generate a reading of the superconductor
14 concentration levels in the samples. Probe 78 may be of any
15 type well known in the art for testing fluid viscosity. This
16 reading is transmitted via line 80 to a microprocessor 82
17 which, depending on the concentration level indicated by the
18 reading from probe 78, will transmit signals via lines 84, 86
19 to supply valve 68 and drain valve 72, respectively, to charge
20 the flow through the valves 68, 72 to effectively maintain the
21 concentration of superconductor particles in slurry 14 in
22 container 12 at the desired level.

23 The thickness of the superconductor ceramic coating of
24 substrate 16 can be automatically controlled using
25 microprocessor 82 in a standard closed loop feedback control
26 system similar to the one used for controlling slurry 14

1 superconductor concentration. Specifically, any device 88,
2 that is well known in the art for measuring the diameter of a
3 wire, can be positioned relative to substrate 16 to determine
4 the diameter of the ceramic coated substrate 16. This
5 measurement can then be sent as an electrical signal via line
6 90 to microprocessor 82. Microprocessor 82 then compares the
7 signal from device 88 with a predetermined reference level to
8 establish an error signal. This error signal is then sent via
9 line 92 to rheostat 38 and, depending on the sign and magnitude
10 of this error signal, rheostat 38 is moved to vary the voltage
11 level of source 24 to control the thickness of superconductor
12 ceramic coating on substrate 16.

13 It is to be appreciated that when 1-2-3 superconductor
14 materials are used, the herein disclosed method for coating a
15 metallic substrate 16 with a superconductor coating must be
16 accomplished in a substantially moisture-free environment.
17 This is so in order to preserve the coatability of the slurry
18 and prevent contamination of the superconductor material.
19 Accordingly, it is preferable that apparatus 10 be enclosed in
20 a dry room where the ambient humidity and carbon dioxide
21 concentrations can be controlled and maintained at very low
22 levels.

23 While a particular apparatus for manufacturing a
24 superconductor as herein shown and disclosed in detail is fully
25 capable of obtaining the objects and providing the advantages
26 herein before stated, it is to be understood that it is merely

1 illustrative of the presently preferred embodiments of the
2 invention and that no limitations are intended to the details
3 of construction or design herein shown other than as described
4 in the appended claims.
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CLAIMS

1. An apparatus for manufacturing a ceramic superconductor having oxygen and copper constituents which comprises:

a container for holding a solution, said solution including a nonaqueous solvent, a charging agent and superconductor particles suspended therein to form a slurry;

a voltage source;

an electrode electrically connected to said voltage source and having a portion thereof submersed in said slurry;

a substrate electrically connected with said voltage source to establish said substrate as a counterelectrode having at least a portion thereof submersed in said slurry;

means for influencing a voltage level from said voltage source to cause said superconductor particles to attach to said substrate; and

a magnet device positioned externally to said container to influence said slurry with a magnetic field.

2. An apparatus for manufacturing a superconductor as recited in claim 1 wherein said magnet device comprises a pair of permanent magnets, each of said magnets being positioned externally to said container with said container therebetween to establish a magnetic field through said solution for aligning said superconductor particles.

3. An apparatus for manufacturing a superconductor as recited in claim 1 wherein said magnet device is a solenoid.

4. An apparatus for manufacturing a superconductor as recited in claim 1 wherein said container further comprises:

an inlet;

means for continuously feeding said substrate into said slurry through said inlet; and

means for withdrawing said substrate with said attached superconductor particles from said slurry.

5. An apparatus for manufacturing a superconductor as recited in claim 4 wherein said substrate is a wire.

6. An apparatus for manufacturing a superconductor as recited in claim 1 wherein said substrate is made of a material having a native oxide for forming a surrounding layer of oxide on said substrate.

7. An apparatus for manufacturing a superconductor as recited in claim 1 wherein said substrate further comprises an oxide barrier layer on the surface of said substrate.

8. An apparatus for manufacturing a superconductor as recited in claim 4 further comprising means for maintaining the concentration of said superconductor particles suspended in said solution at a predetermined level.

9. An apparatus for manufacturing a superconductor as recited in claim 8 wherein said concentration maintaining means comprises:

a drain valve incorporated into said container for withdrawing relatively lower superconductor concentration slurry from said container; and

a tank containing a slurry of relatively higher superconductor concentration solution, said tank having a supply valve operable to introduce predetermined amounts of said relatively high superconductor concentration slurry into said container.

10. An apparatus for manufacturing a superconductor as in claim 9 wherein said concentration maintaining means further comprises:

a sampling probe mounted on said container and inserted into said slurry in said container for obtaining samples thereof;

means for determining the concentration level of superconductor materials in said slurry in said container; and

means responsive to the concentration level to activate said drain valve and said supply valve to maintain the concentration of said slurry in said container at the predetermined level.

11. An apparatus for manufacturing a superconductor as recited in claim 4 further comprising means for cleaning said substrate before said substrate is fed into said container.
12. An apparatus for manufacturing a superconductor as recited in claim 1 further comprising means for rotating said substrate in said container to provide for uniform attachment of said superconductor particles to said substrate under the influence of the magnetic field generated by said magnet device.
13. An apparatus for manufacturing a superconductor as recited in claim 1 further comprising means for rotating the magnet device around said container to provide for uniform attachment of said superconductor particles to said substrate under the influence of the magnetic field generated by said magnet device.
14. An apparatus for manufacturing a superconductor as recited in claim 1 further comprising means for maintaining said container in an effectively moisture-free environment.
15. An apparatus for manufacturing a superconductor as recited in claim 1 wherein said nonaqueous solvent is isopropanol and said charging agent is ethanolamine.
16. An apparatus for manufacturing a superconductor as recited in claim 1 wherein said superconducting particles are from the group identified as $\text{RE Ba}_2\text{Cu}_3\text{O}_{7-x}$ where x can have values in the range from 0 to 0.1.
17. An apparatus for manufacturing a superconductor as recited in claim 1 wherein said electrode is supported in said slurry at a distance of 1 cm from said counterelectrode substrate.
18. An apparatus for manufacturing a superconductor as recited in claim 5 wherein said wire substrate is alumel.

19. An apparatus for manufacturing a superconductor as recited in claim 5 wherein said substrate is Hoskins™ 875.

20. An apparatus for manufacturing a superconductor as recited in claim 7 wherein said oxide barrier is barium zirconate.

21. An apparatus for manufacturing a superconductor as recited in claim 1 further comprising:

means for determining the thickness of said superconductor particles on said substrate;
and

means responsive to said thickness determining means for varying said voltage level to maintain the thickness of said superconductor particles on said substrate at a preselected thickness.

22. An apparatus for electrically coating a metal substrate with ceramic superconductor particles having oxygen and copper constituents which comprises:

means for holding a slurry of superconductor particles suspended in a nonaqueous solution;

a magnet device positioned adjacent said holding means for influencing said slurry with a magnetic field;

means for electrically biasing said substrate; and

means for suspending said substrate in said slurry to attach said superconductor particles thereto in a magnetically aligned orientation thereof.

23. An apparatus for electrically coating a metal substrate with superconductor particles as recited in claim 22 wherein said holding means is a metal container.

24. An apparatus for electrically coating a metal substrate with superconductor particles as recited in claim 22 wherein said means for electrically biasing said substrate is a voltage source electrically connected with said holding means to establish said holding means as

an electrode and electrically connected with said substrate to establish said substrate as a counterelectrode.

25. An apparatus for electrically coating a metal substrate with superconductor particles as recited in claim 22 further comprising means for agitating said superconductor particles to establish a charge thereon.

26. An apparatus for manufacturing a superconductor as recited in claim 22 wherein said magnet device comprises a pair of permanent magnets, each of said magnets being positioned externally to said holding means with said holding means therebetween to establish a magnetic field through said solution for aligning said superconductor particles.

27. An apparatus for manufacturing a superconductor as recited in claim 22 wherein said magnet device is a solenoid.

28. A method for coating a metal fiber with superconductor particles which comprises the steps of:

submersing an electrode from a voltage source into a container filled with a solution having charged superconducting particles suspended therein to form a slurry;

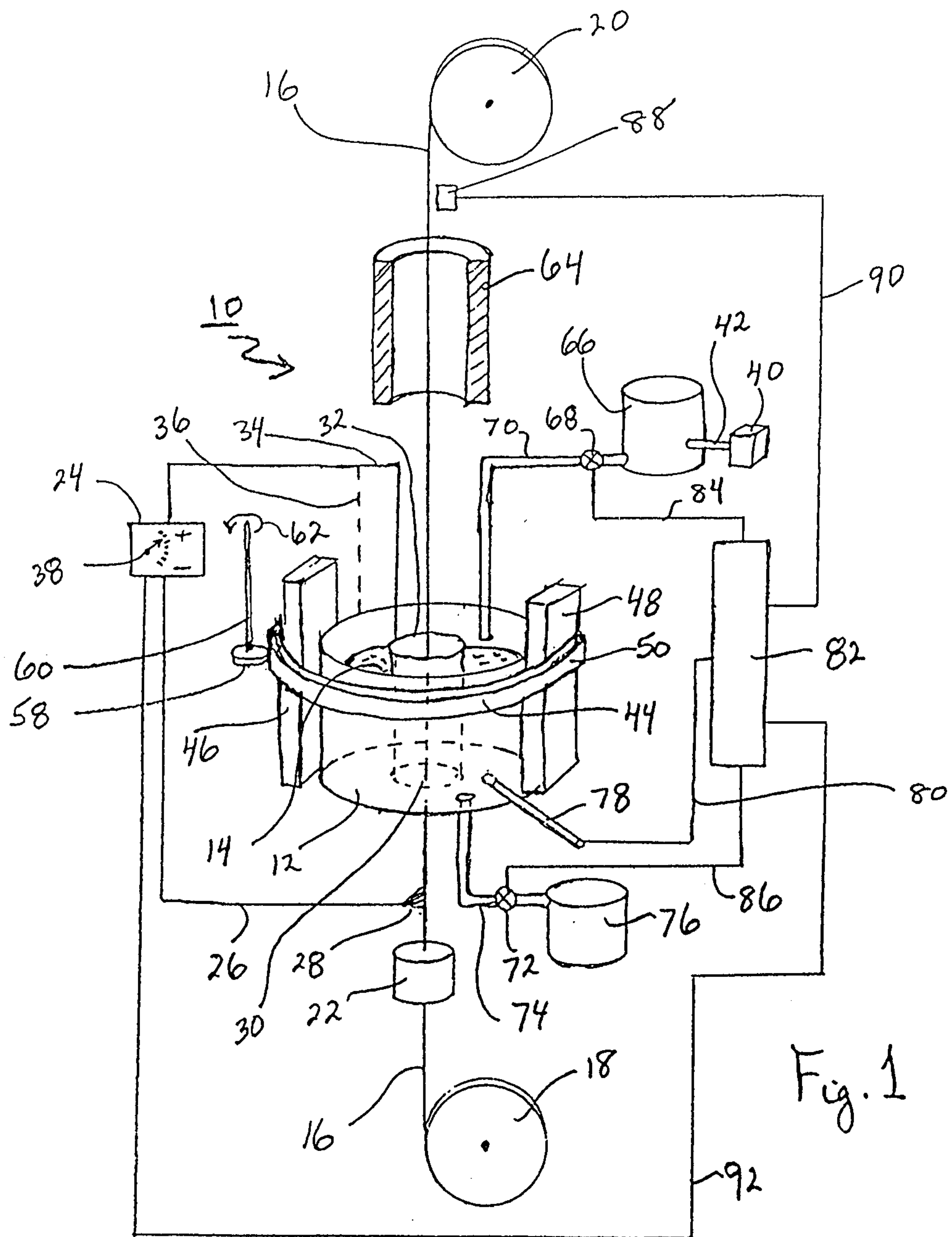
connecting said fiber to said voltage source to establish said fiber as the counterelectrode thereof;

positioning a magnet device external to said container to influence said slurry with a magnetic field for aligning said particles in a selected orientation on said fiber; and

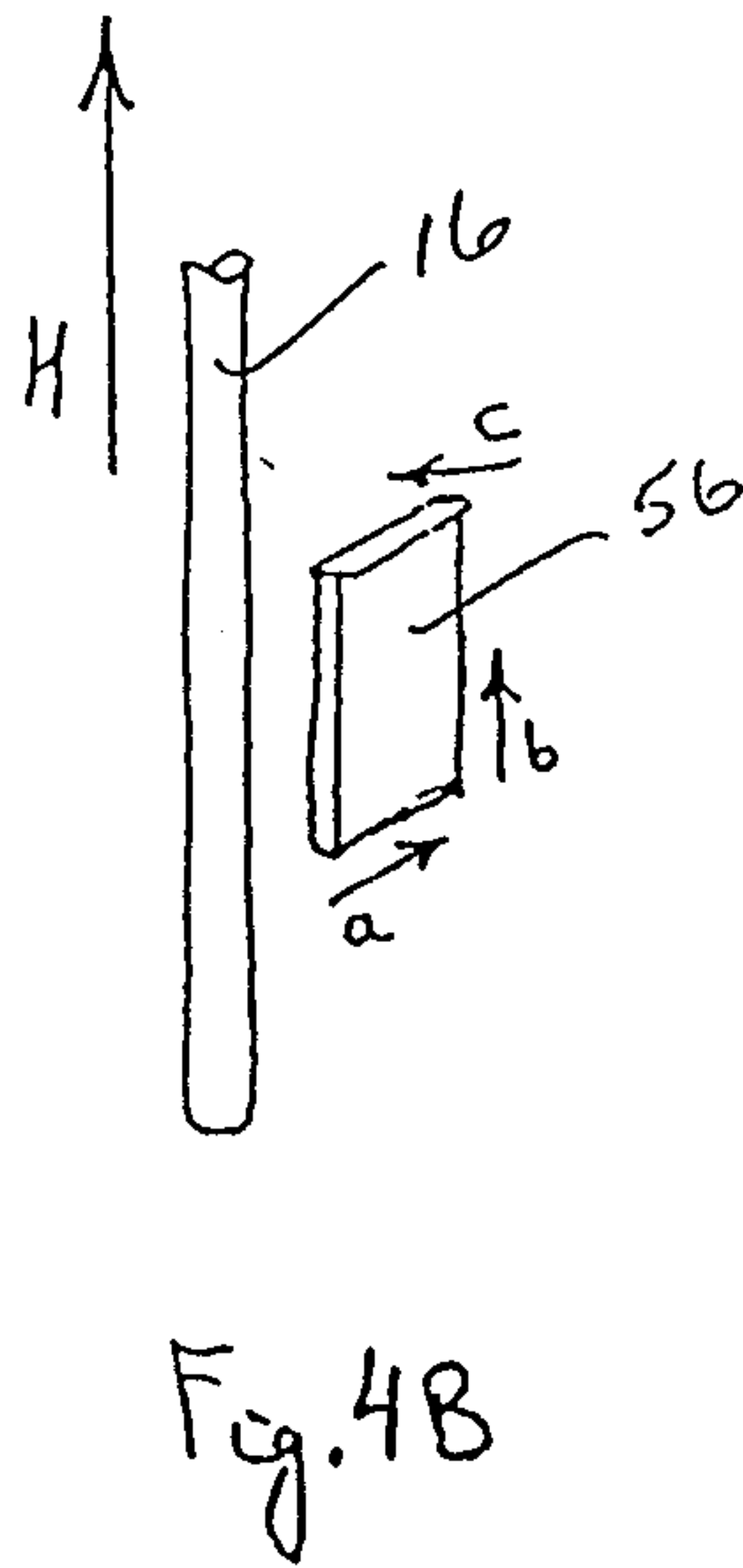
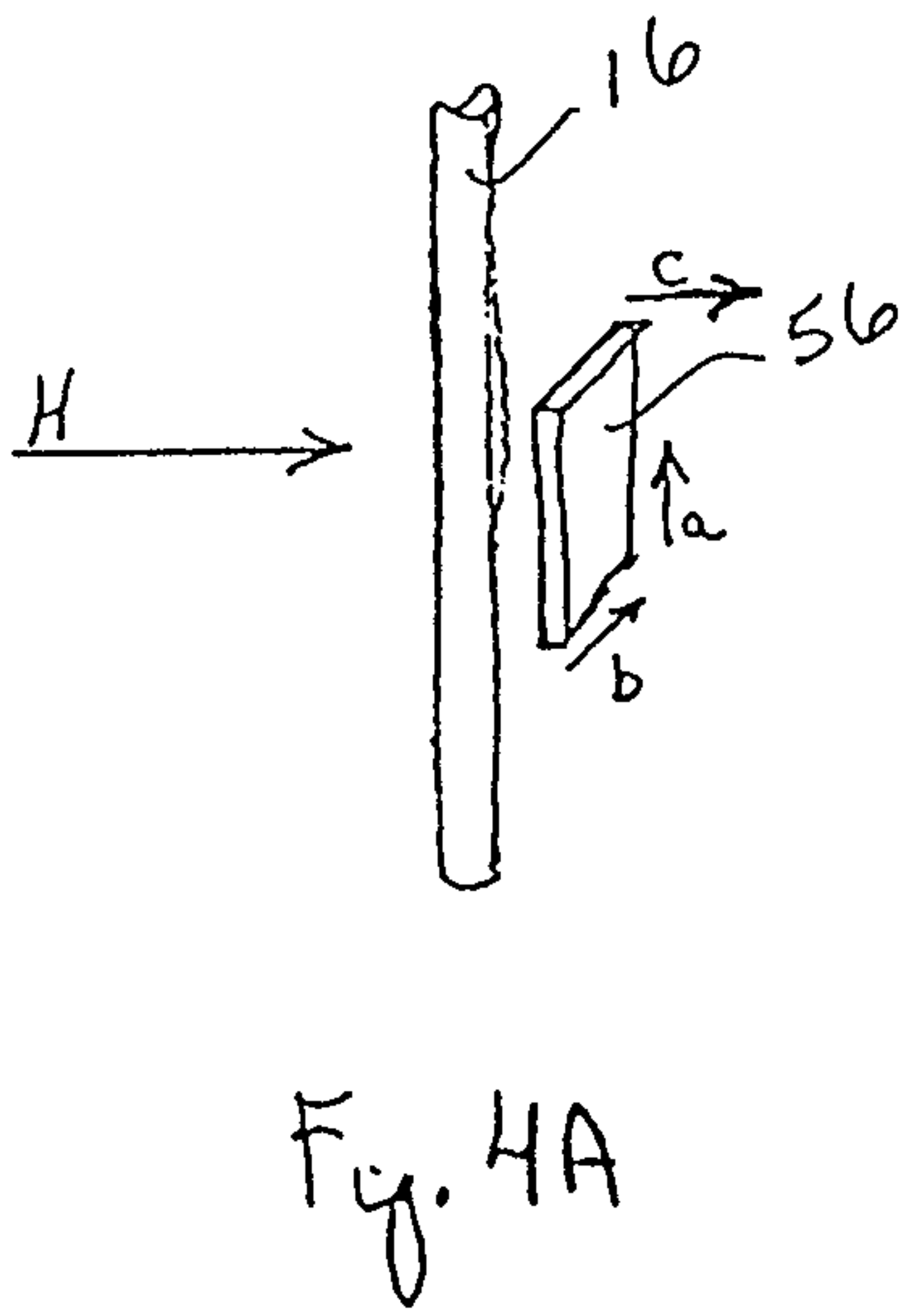
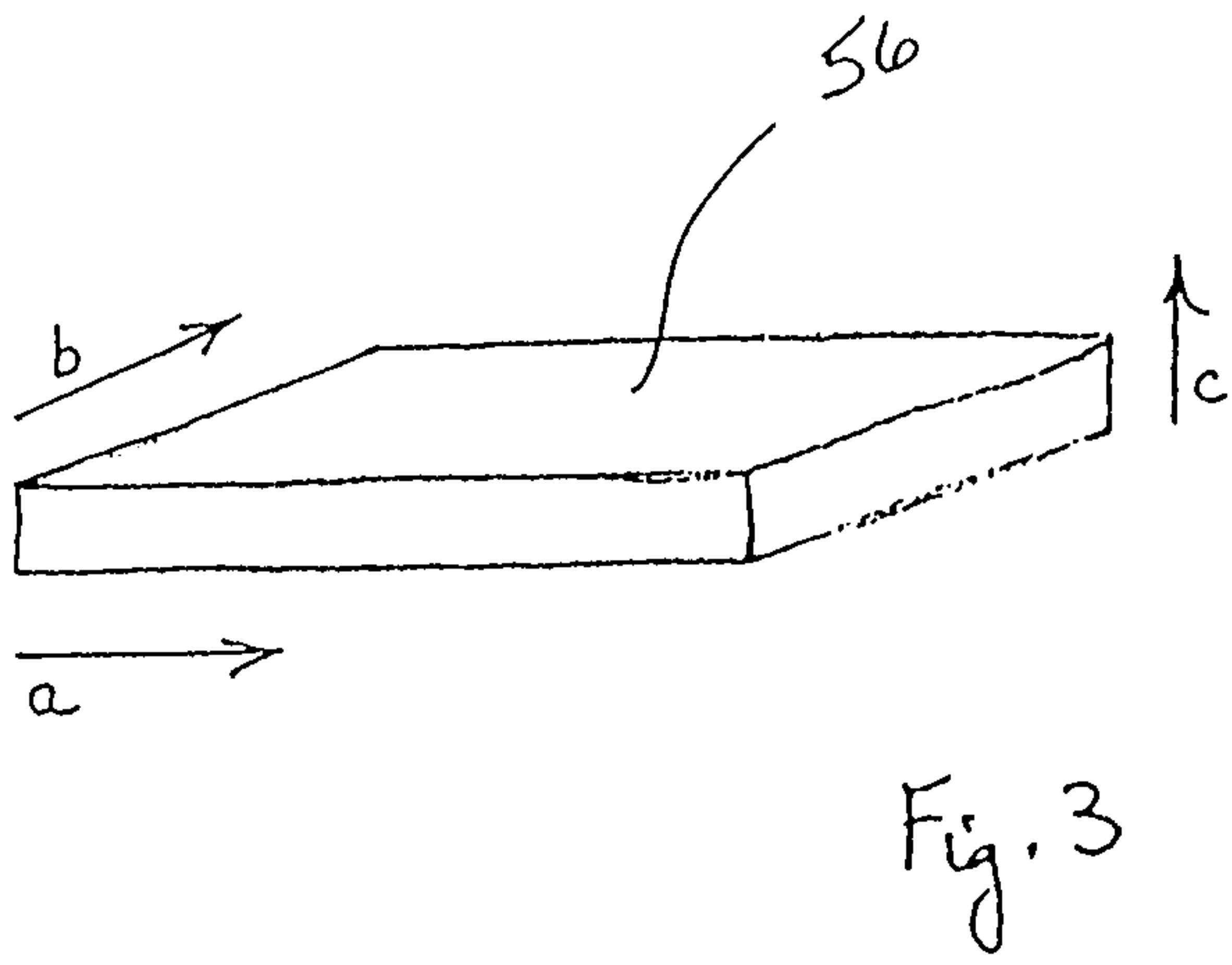
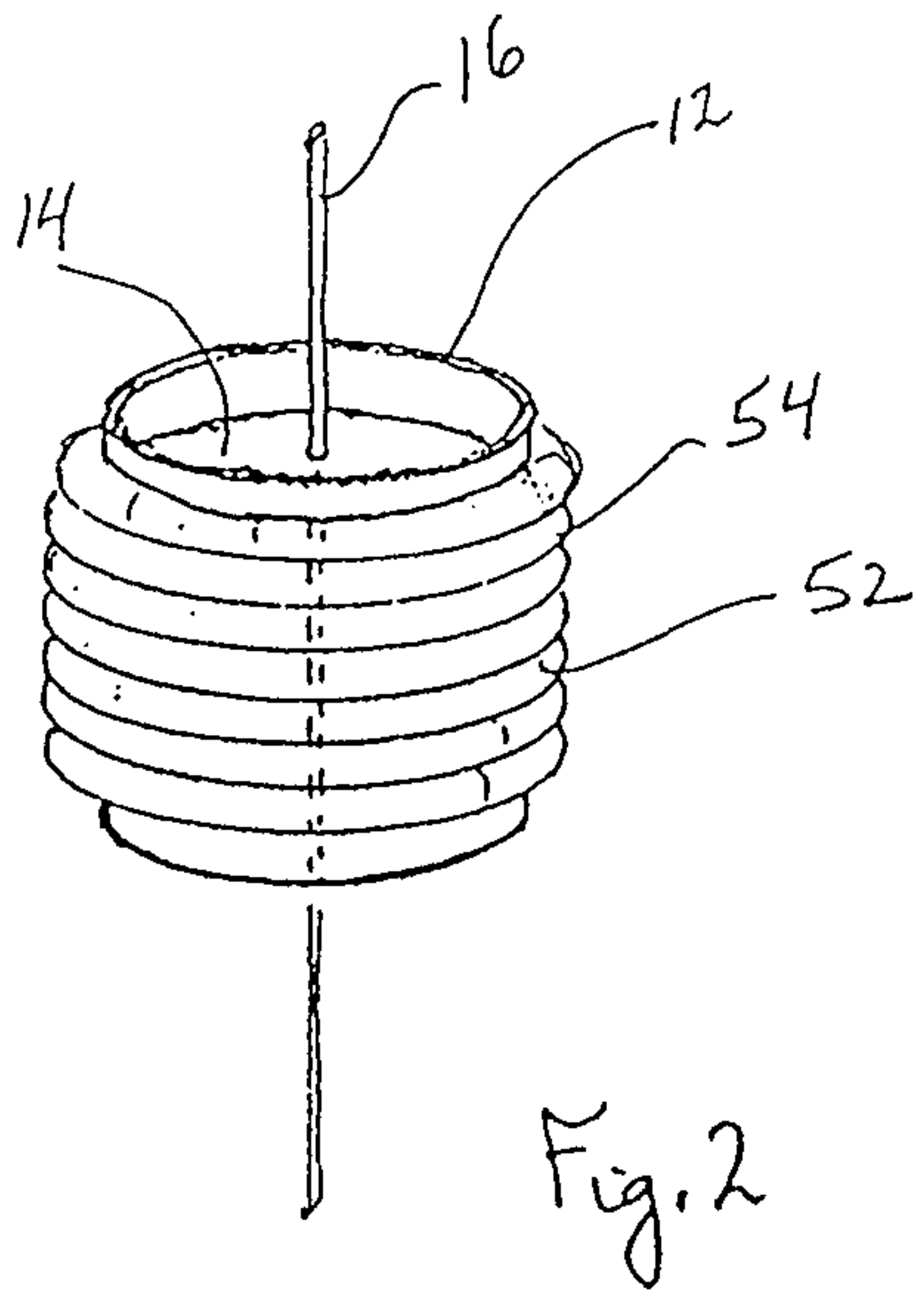
submersing said fiber into said slurry to attach said particles thereto to coat said fiber.

29. A method for coating a metal fiber with superconductor particles as recited in claim 28 wherein the step of submersing said fiber into said slurry comprises drawing said fiber into said slurry through an inlet and withdrawing said fiber with said attached superconductor particles from said slurry.

30. A method for coating a metal fiber with superconductor particles as recited in claim 28 further comprising the step of maintaining the concentration of said suspended particles in said slurry at a predetermined level.
31. A method for coating a metal fiber with superconductor particles as recited in claim 28 further comprising the step of maintaining said container and said slurry in an effectively moisture-free environment.
32. A method for coating a metal fiber with superconductor particles as recited in claim 28 further comprising the step of varying the voltage of said voltage source to obtain the desired thickness of said superconductor particles on said fiber.
33. A method for coating a metal fiber with superconductor particles as recited in claim 28 further comprising the step of agitating said slurry before placing said slurry in said container to enhance the electrical charge on said superconductor particles.
34. A method for coating a metal fiber with superconductor particles as recited in claim 28 further comprising the step of milling said superconductor particles to enhance the charge on said superconductor particles.
35. A method for coating a metal fiber with superconductor particles as recited in claim 28 wherein said slurry is prepared by agitating and mixing together isopropanol, ethanolamine, and superconductor particles.
36. A method for coating a metal fiber with superconductor particles as recited in claim 28 wherein said submersing step is accomplished by submersing said electrode into a nonaqueous solution.



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